



Attorney's Docket No.: 07977-010004 / US2941D1D1

B1 93 IFW \$

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Kusumoto et al.

Art Unit : 2814

Serial No. : 09/903,339

Examiner : Theresa T. Doan

Filed : July 10, 2001

Title : METHOD FOR PRODUCING INSULATED GATE THIN FILM
SEMICONDUCTOR DEVICE

MAIL STOP AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Applicants request consideration of the reference listed on the attached PTO-1449 form.

Submitted herewith is an English translation of the following foreign language reference,
or portions thereof:

Desig. ID	Source
AL	JAPAN 06-333950 – English Abstract: DIALOG(R)File 347:JAPIO (2005); Accession No. 04662050.

This statement is being filed after a Notice of Allowance, but before payment of the issue fee. The undersigned certifies that the reference included in the information disclosure statement was first cited in a communication from a foreign patent office in a counterpart foreign application received on October 25, 2005, which is not more than three months prior to the filing of this information disclosure statement.

A check for \$180 in payment of the late submission fee of §1.17(p) is enclosed. Please apply any other charges or credits to Deposit Account No. 06-1050.

11/14/2005 SZEWDIE1 00000040 09903339

01 FC:1806

Date: 11/10/05 180.00 OP

Respectfully submitted,



John F. Hayden
Reg. No. 37,640

Fish & Richardson P.C.
1425 K Street, N.W., 11th Floor
Washington, DC 20005-3500
Telephone: (202) 783-5070
Facsimile: (202) 783-2331
40310367.doc

Sheet 1 of 1

Substitute Form PTO-1449 (Modified) Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.98(b))	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 07977-010004	Application No. 09/903,339
	Applicant Kusumoto et al.		
	Filing Date July 10, 2001	Group Art Unit 2814	

U.S. Patent Documents

Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

Foreign Patent Documents or Published Foreign Patent Applications

Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AL	JP 06-333950	12/02/1994	Japan			Abst.	
	AM							
	AN							
	AO							
	AP							

Other Documents (include Author, Title, Date, and Place of Publication)

Examiner Initial	Desig. ID	Document
	AQ	
	AR	
	AS	
	AT	

Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	